

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT(S):

Card et al.

SERIAL NO.:

10/656,607

**GROUP NO.:** 

Not yet assigned

FILING DATE:

September 5, 2003

**EXAMINER:** 

Not yet assigned

TITLE:

Intelligent Control for Process Optimization and Parts Maintenance

### CERTIFICATE OF FIRST CLASS MAILING UNDER 37 C.F.R. 1.8

I hereby certify that this correspondence, and any document(s) referred to as enclosed herein, is/are being deposited with the United States Postal Service as first class mail, postage prepaid, in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on this **30** day of September, 2003.

Susan Boucher

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Submitted herewith is/are:

Transmittal Form (1 page); Information Disclosure Statement (3 pages); PTO Form 1449 (2 pages); copies of cited references (A-A5, B1-B2, C1-C13); and a return-receipt postcard.

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U 350			Application Serial Number	10/6	556,607			
TRADEMARKE			Filing Date	September 5, 2003				
			First Named Inventor	Card				
	TRANSMITTA	T	Group Art Unit	Not yet assigned				
FORM			Examiner Name	Not	Not yet assigned			
			Attorney Docket No.	IBX	IBX-008			
			Patent No.	Not	Not applicable			
			Issue Date	Not applicable				
		E	NCLOSURES (check all that apply)					
☐ F	ee Transmittal Form		Copy of Notice to File Missing Parts of Application (PTO-1553)		Notice of Appeal to Board of Patent Appeals and Interfe			
	☐ Check Attached☐ Copy of Fee Transmittal Form		Formal Drawing(s)		Appeal Brief (in triplicate)			
	Amendment/Response		Request For Continued		Status Inquiry			
	☐ Preliminary		Examination (RCE) Transmittal					
	After Final Affidavits/declaration(s)		Power of Attorney		Return Receipt Postcard			
	Letter to Official Draftsperson		(Revocation of Prior Powers)	⊠	Certificate of First Class Mai under 37 C.F.R. 1.8			
	including Drawings [Total Sheets]		Terminal Disclaimer		Certificate of Facsimile Transmission under 37 C.F.R			
	Petition for Extension of Time		Executed Declaration and Power of Attorney for Utility or Design Patent Application		Additional Enclosure(s) (please identify below)			
$\boxtimes$	Information Disclosure Statement		Small Entity Statement					
	<ul><li>✓ Form PTO-1449</li><li>✓ Copies of IDS</li><li>Citations</li></ul>		CD(s) for large table or computer program	:				
	Certified Copy of Priority Document(s)		Amendment After Allowance					
	Sequence Listing submission Paper Copy/CD Computer Readable Copy Statement verifying identity of above		Request for Certificate of Correction Certificate of Correction (in duplicate)					

CORRESPONDENCE ADDRESS

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Date: September 20, 2003 Reg. No. 33,497 Tel. No.: (617) 310-8108 Fax No.: (617) 790-0178

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Respectfully submitted,



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Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## INFORMATION DISCLOSURE STATEMENT

Sir:

In accordance with the provisions of 37 C.F.R. 1.97 and 1.98, Applicants hereby make of record the patents and publications listed on the accompanying Form PTO-1449, and other information contained herein, for consideration by the Examiner in connection with the examination of the above-identified patent application. Copies of the patents and publications are enclosed.

#### **REMARKS**

In accordance with the provisions of 37 C.F.R. 1.97, this statement is being filed (CHECK ONE):

(1)	within three (3) months of the <b>filing date</b> of a national application other than a continued prosecution application under 37 C.F.R. 1.53(d), or within three (3) months of the <b>date of entry of the national stage</b> as set forth in 37 C.F.R. 1.491 in an international application, or before the mailing of the <b>first Office action</b> on the merits, or before the mailing of a <b>first Office action</b> after the filing of a request for continued examination under 37 C.F.R. 1.114; or
(2)	after the period defined in (1) but before the mailing date of a final action or a notice of allowance under 37 C.F.R. 1.311, and
	the requisite Statement is below, OR
	the requisite fee under 37 C.F.R. 1.17(p), namely \$180.00, is included herein, or

Page 2 of 3		
	(3)	after the mailing date of a final action or notice of allowance but before the payment of the issue fee, AND
		the requisite Statement is below, AND
		the requisite petition fee under 37 C.F.R. 1.17(p), namely \$180.00 is included herein.
	•	fully requested that each of the patents and publications listed on the attached Form the information contained herein, be made of record in this application.
		STATEMENT
As re	quired	under 37 C.F.R. 1.97(e), Applicant(s), through the undersigned, hereby state either that
[check the	appro	priate space only if either (2) or (3) is checked on the previous page <u>and</u> the
Statement	t is req	uired]:
	] 1	Each item of information contained in the Information Disclosure Statement was first cited in any communication from a foreign patent office in a counterpart foreign application <b>not more than three months</b> prior to the filing of the Information Disclosure Statement; or
	] 2	No item of information contained in the Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application, and, to the knowledge of the person signing this Statement after making reasonable inquiry, no item of information contained in the Information Disclosure Statement was known to any individual designated in 37 C.F.R. 1.56(c) more than three months prior to the filing of the Information Disclosure Statement.
		Applicant wishes to inform the Examiner about the following co-pending patent lications, issued patents, and Office Actions issued therein:
U.S.	Serial	No. 10/243,963, filed on September 13, 2002, by Card et al. (IBX-001);
		No. 10/244,154, filed on September 13, 2002, by Reitman et al. (IBX-002);

U.S. Serial No. 10/645,209, filed on August 21, 2003, by Chan et al. (IBX-004); and

U.S. Serial No. 10/621,532, filed on July 17, 2003, by Card et al. (IBX-005).

Information Disclosure Statement

Serial No. 10/656,607

Information Disclosure Statement Serial No. 10/656,607 Page 3 of 3

Date: September 30, 2003

Reg. No. 33,497

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Respectfully submitted,

Steven J. Frank

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FORM PTO - 1449 INFORMATION DISCLOSURE STATEMENT				ATTORNEY DOCKET NO.: IBX-008  APPLICANT(S): Card et al.  SERIAL NO.: 10/656,607							
FILING DATE: 9/5/03 GROUP: Not yet assigned											
			U.S.	PATENT	DOCUMI	ENTS		****	•		
EXAM. INIT.		DOCUMENT NUMBER	DATE	NAME CLASS SUB CLASS			FILING DATE IF APPROPRIATE				
	A1	5,467,883	11/21/95	Frye et al.			216	60	11/27/93		
_	A2	5,559,690	9/24/96	Keeler et al.			364	164	9/16	9/16/94	
	A3	5,654,903	8/5/97	Reitman et al.			364	551.01	11/7	11/7/95	
	A4	5,740,033	4/14/98	Wassick et al.			364	149	10/1	3/92	
	A5	6,268,226	7/31/01	Angell et al.			438	16	6/30	)/99	
			FOREI	GN PATE	NT DOCU	MENTS	· · · · · ·				
EXAM. INIT.		DOCUMENT NUMBER	DATE	COUNTRY CODE	CLASS	SUB CLASS	FILING DATE	ABSTR ONLY	ABSTRACT EI ONLY LA (Y		
	Bi	WO 01/57605	8/9/01	wo	G05B	13/04	1/11/01	N		Y	
	B2	DE196 37 917 A1	3/19/98	DE	G05B	13/04	9/17/96	Y			
		<u> </u>	THER AR	RT, JOURN	  AL ART	  CLES, E	TC.	<u> </u>			
EXAM. INIT.	ОТН	ER DOCUMENTS	: (Including	Author, Tit	le, Date, Re	levant Pag	ges, Place o	f Publicat	ion)		
-	C1 Card et al., "Dynamic Neural Control for Plasma Etch Process," IEEE Transactions on Neural Networks, (1997).										
	C2	Card et al., "Impacts of Maintenance Input on the Prediction Accuracy of an APC Controller," Presentation at AEC/APC Symposium XIV (September 9-11, 2002).									
	C3	Card et al., "Advanced Analysis of Dynamic Neural Control Advisories for Process Optimization and Parts Maintenance," Presentation at AEC/APC Symposium XIV (September 9-11, 2002).									
	C4	C4 Dillon et al., "Guest Editorial Everyday Applications of Neural Networks," <u>IEEE Transactions on Neural Networks</u> , 8:4 (July 1997).					on Neural				
	C5 Hatzipantelis et al., "Comparing Hidden Markov Models with Artificial Neural Network Architectures for Condition Monitoring Applications," <u>Artificial Neural Networks</u> , 26-28, Conference Publication No. 409 (June 1995).										

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EXAMIN	NER	DATE CONSIDERED					
		Proceedings of AEC/APC (2000).					
	C12 Smyth et. al., "Hidden Markov Models an Neural Networks for Fault detection in Dynamic Systems, California Institute of Technology (1993).  C13 Zhang et al, "Control of Spatial Uniformity in Microelectronics Manufacturing: An Integrated Appro						
	C11	Rietman, "Neural Networks in Plama Processing," <u>Journal of Vacuum Science and Technology: Part B, IEEE Transactions on Semiconductor Manufacturing</u> , 14:1 (2001).					
C10 Rietman et al., "A System Model for Feedback Control and Analysis of Yield: A Multistep Pro Effective Gate Length, Poly Line Width, and IV Parameters", IEEE (2001).							
	C9	Rietman et al., "A Study on $\Re^m \to \Re^1$ Maps: Application to a 0.16- $\mu$ m Via Etch Process Endpoint," <u>IEEE</u> (2000).					
	C8	Moyne, "AEC/APC Vision: A Research and Suppliers' Point of View," 3 <sup>rd</sup> Annual European AEC/APC Conference Proceedings (2002).					
	C7	Konstantopoulos et al., "Controllers with Diagnostic Capabilities. A Neural Network Implementation.  Journal of Intelligent and Robotic Systems," Department of Electrical Engineering, University of Notre  Dame, IN 12: 197-228 (1995).					
	C6	Kim et al., "Intelligent Control of Via Formation by Photosensitive BCB for MCM-L/D Applications," <u>IEEE Transactions on Semiconductor Manufacturing</u> , 12:503 (1999).					